

# APPLICATION DATA SHEET

## APPLICATION INFORMATION

Application Type:: REGULAR  
 Subject Matter:: UTILITY  
 CD-ROM or CD-R?:: NONE  
 Title:: POLYGON-TYPE SEMICONDUCTOR  
 DETECTOR FOR USE IN HIGH-SPEED  
 X-RAY CT, AND MANUFACTURING  
 METHOD THEREFOR  
 Attorney Docket Number:: 218866US2  
 Total Drawing Sheets:: 1

## INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR  
 Primary Citizenship Country:: Japan  
 Status:: FULL CAPACITY  
 Given Name:: Masaki  
 Family Name:: MISAWA  
 City of Residence:: Ibaraki  
 Country of Residence:: Japan  
 Street of Mailing Address:: 4-407-106 Matsushiro, Tsukuba  
 City of Mailing Address:: Ibaraki  
 Country of Mailing Address:: Japan  
 Postal or Zip Code of Mailing Address:: 305-0035

## CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

## REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

## FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2001-023141	Japan	01/31/01	YES

## ASSIGNMENT INFORMATION

Assignee Name:: National Inst. of Advanced Ind. Science  
 and Tech.  
 Street of Mailing Address:: 3-1, Kasumigaseki 1-chome, Chiyoda-ku

2001-023141

City of Mailing Address::  
Country of Mailing Address::

Tokyo  
Japan

2006-10-01 10:00:00